Docket No.: 0216-0516PUS1 (Patent)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:

Toshihiko OHASHI et al.

Application No.: 10/541,776 Confirmation No.: 1474

Filed: July 08, 2005 Art Unit: 1794

For: SILICA-CONTAINING LAMINATED Examiner: V. CHANG

STRUCTURE, AND COATING

COMPOSITION FOR USE IN FORMING A POROUS SILICA LAYER

## REPLY UNDER 37 C.F.R. § 1.114

MS AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## INTRODUCTORY COMMENTS

In reply to the Office Action dated December 17, 2009, the following amendments and remarks are respectfully submitted with a Request for Continued Examination (RCE) in connection with the above-identified application.

Remarks begin on page 2.